

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	
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Naoki Komai, et al.)	Group Art Unit: 1742
)	
Application No. 10/762,691)	Confirmation No.: 5255
)	
Filed: January 22, 2004)	
)	
For: ELECTROPOLISHING APPARATUS AND)	Examiner: Nicholas A. Smith
POLISHING METHOD)	

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT
BEFORE MAILING DATE OF EITHER A FINAL OFFICE ACTION
OR NOTICE OF ALLOWANCE (37 C.F.R. § 1.97(C))**

**TIME OF TRANSMITTAL OF ACCOMPANYING
INFORMATION DISCLOSURE STATEMENT**

The identified were references cited in an Office Action issued on May 8, 2007, for counterpart Japanese Application No. 2003-015928 filed on September 20, 2000. A copy of the reference and the Office Action are submitted herewith. None of the cited references are in English and a machine translation for each one is enclosed.

The filing of this information disclosure statement shall not be construed as a representation that a search has been made (37 C.F.R. § 1.97 (g)), an admission that the information cited is, or is considered to be, material to patentability, or that no other material information exists.

The filing of this information disclosure statement shall not be construed as an admission against interest in any manner.

Applicant submits herewith a payment via the electronic submission process in the amount of \$180.00, the fee set forth in 37 C.F.R. § 1.17(p) for submission of an information disclosure statement under § 1.97 (c).

The Commissioner is hereby authorized to credit overpayments or to charge any deficiency in a required fee not already covered by the credit card payment to Deposit Account No. 19-3140.

Dated:

July 30, 2007

By:

Respectfully submitted,

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